

Application/Control No.	Applicant(s)/Patent under Reexamination
10/743,688	RUDEN ET AL.
Examiner	Art Unit
A Dexter Tughang	3729

SEARCHED				
Class	Subclass	Date	Examiner	
29	603.03 603.01 604 901	10/19/2007	ADT	
	729 759			
	760			
360	98.07			
	99.08			
	98.01			
	99.2 135			
Updated	(above)	6/17/2008	ADT	
360	77.04			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Text Search: NPL - IEEE Xplore Database	10/19/2007	ADT		